

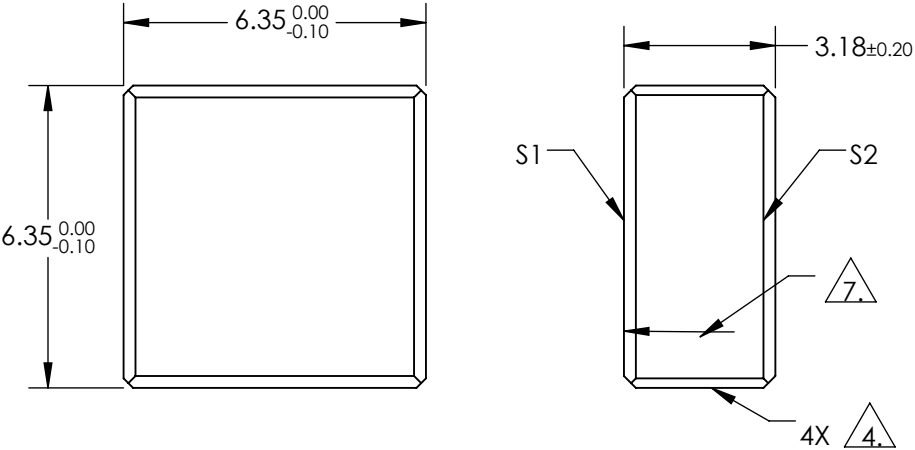
NOTES:

1. SUBSTRATE:
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 532nm
DAMAGE THRESHOLD,
PULSED: 10 J/cm² @ 532nm, 20ns, 20Hz

S2: NONE

4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2	<div><div><div><div></div></div></div><div>Edmund Optics®</div></div> <div><div>THIRD ANGLE PROJECTION</div><div></div></div> <div><div>TITLE</div><div>6.35 x 6.35mm 532nm 0-45°, Nd:YAG Laser Line Mirror</div></div> <div><div>DWG NO</div><div>39645</div></div> <div><div>SHEET</div><div>1 OF 1</div></div>
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